



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63680

Kohei ABUKAWA

Appln. No. 09/821,020

Group Art Unit: 1775

Confirmation No.: 5550

Examiner: Archene Turner

Filed: March 30, 2001

For: SILICON NITRIDE MEMBER, METHOD FOR MANUFACTURING THE SAME,  
AND CUTTING TOOL

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

This is in Reply to the Restriction Requirement dated May 24, 2002. Applicant elects Group I 1-4 (drawn to a product) without traverse.

Respectfully submitted,

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